

Lecture 14: Beam Combos II

• Announcements:

- HW#4 online soon, due Tuesday, 3/17, at 8 a.m.
- Midterm Exam: Thursday, March 19, 9:30-11:00 a.m., 521 Cory (right here)
- UC Berkeley has stopped ground classes in an effort to suppress Coronavirus
- This is a video-recorded lecture, as will be subsequent lectures until the university goes back to ground classes
- Office hours are going to Zoom per my recent Piazza post

• Reading: Senturia, Chpt. 9

• Lecture Topics:

- ↳ Bending of beams
- ↳ Cantilever beam under small deflections
- ↳ Combining cantilevers in series and parallel
- ↳ Folded suspensions
- ↳ Design implications of residual stress and stress gradients

• Last Time:

- Finished beam combinations and mechanical spring circuits, using a mechanical filter example
- Now, continue with examples and methods for handling stress in beam combos

Micromedical Filter

Input Electrode, Suspension Beam, Coupling Beam, Output Electrode, Anchors, Shuttle 1, Folding Truss, Anchors, Shuttle 2, Point A, Point B.

Dimensions: $200\ \mu\text{m}$, $100\ \mu\text{m}$, $2\ \mu\text{m}$.

Handwritten notes:

- k_c (coupling beam stiffness)
- m_1 (mass of shuttle 1)
- m_2 (mass of shuttle 2)
- $k_A = \frac{F}{x_A}$ (stiffness at point A)
- $k_A \triangleq \text{stiffness @ point A}$
- Want this
- Assume: shuttles & folding truss are rigid.
- beams are small \therefore neglect their mass

Equivalent circuit diagram below:

Equivalent circuit: Anchor \rightarrow k_c \rightarrow m_1 \rightarrow k_b \rightarrow m_2 \rightarrow k_c \rightarrow Anchor.

Labels: k_{combined} , F , x_A , k_c , k_b , m_1 , m_2 , k_c , k_A .

Notes: $k_b = ?$, need the k_b .

Get k_b :

series $\rightarrow \frac{k_{cs}}{2}$

series $\rightarrow \frac{k_{cs}}{4}$

free

cantilever $\rightarrow k_{cs}$ ("coupling springs")

parallel $\rightarrow \frac{k_{cs}}{2} = k_b$

$\therefore k_A = k_c + k_{combined}$

$k_c + k_c || k_b = k_c + k_c || \frac{k_{cs}}{2} = k_A$

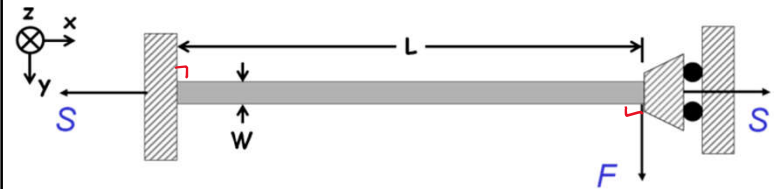
where $k_c = \frac{24EIz}{L^3}$

$k_{cs} = \frac{24EIz}{L_{cs}^3}$

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Tensioned Spring (Non-Ideality)

- Important case for MEMS suspensions, since the thin films comprising them are often under residual stress
- Consider small deflection case: $y(x) \ll L$



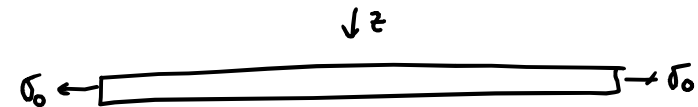
Governing differential equation: (Euler Beam Equation)

$$EI_z \frac{d^4 y}{dx^4} - S \frac{d^2 y}{dx^2} = F \delta(x-L)$$

Axial Load Unit impulse @ $x=L$

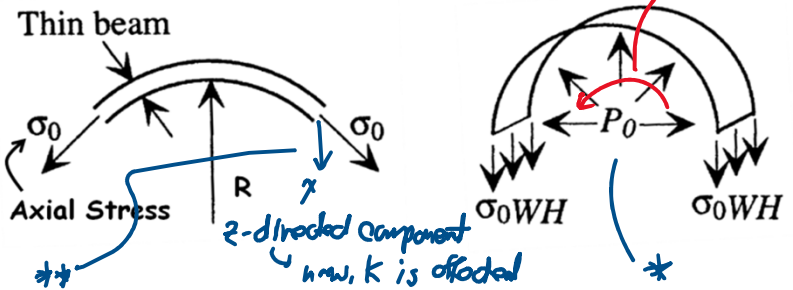
Heuristic Derivation for the Euler Beam Equation

Consider first a straight beam under an axial stress:



\Rightarrow no effect on 2-dimmed stiffness when the beam is straight

... but when the beam bends:




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* Upward pressure P_0 to counteract the downward force from σ_0 to keep everything in static equilibrium

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For ease of analysis:
Assume the beam bends to an angle π
Downward vertical force: $2\sigma_0 WH$

Get upward force due to P_0 :



$P_2(\theta) = P_0 \sin \theta$
 $F_u = \int_0^\pi (P_0 \sin \theta) W (R d\theta)$
 $= -P_0 W R \cos \theta \Big|_0^\pi$
 $= 2RW P_0$

[Equilibrium] $\rightarrow 2RW P_0 = 2\sigma_0 WH \rightarrow P_0 = \frac{\sigma_0 H}{R}$

$\left[q_0 = \frac{\text{beam load}}{\text{unit length}} = P_0 W, \frac{1}{R} = \frac{d^2 w}{dx^2} \right]$ beam displacement

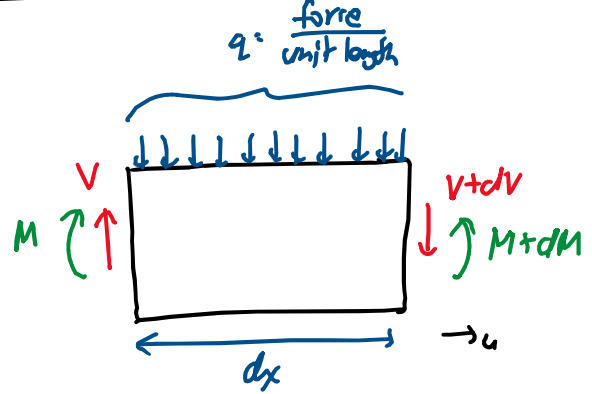
$q_0 = \sigma_0 WH \frac{d^2 w}{dx^2}$ generalizes to the case of small displacements & angles

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Using the Differential Beam Bending Eq

$+\frac{d^2 w}{dx^2} = -\frac{M}{EI} \rightarrow \frac{d^4 w}{dx^4} = \frac{q}{EI}$ (load/unit length)

* Relationship Between Forces & Moments on a Fully-Loaded Differential Beam Element



[Total Static Equilibrium] \Rightarrow total force = 0

$F_T = \text{total force} = q dx + (V+dV) - V = 0$

$\therefore \frac{dV}{dx} = -q$ (1)

\Rightarrow also, total moment wrt to left-hand edge = 0

$M_T = (M+dM) - M - (V+dV) dx - \frac{1}{2} q dx^2 = 0$

neglect products of differentials $\int_0^{dx} (q du) = \frac{1}{2} q dx^2$

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$$dM - V dx = 0 \rightarrow \boxed{\frac{dM}{dx} = V} \quad (2)$$

Using (1) & (2):

$$\left[\frac{d^2 M}{dx^2} = \frac{dV}{dx} = -q \right]$$

external load

$$EI \frac{d^4 w}{dx^4} = q + q_0$$

equiv. load from axial stress

$$[q_0 = \sigma_0 W H \frac{d^2 w}{dx^2}] \Rightarrow$$

$$EI \frac{d^4 w}{dx^4} - (\sigma_0 W H) \frac{d^2 w}{dx^2} = q$$

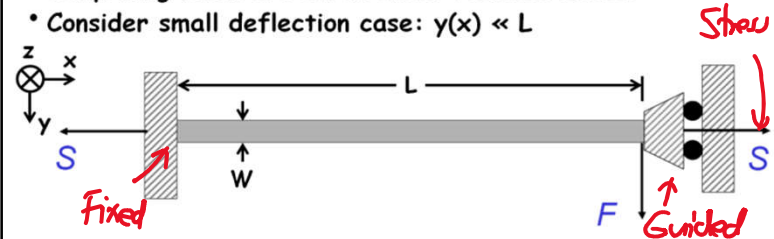
tension in beam = S

Euler Beam Equation

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Clamped-Guided Beam Under Axial Load

- Important case for MEMS suspensions, since the thin films comprising them are often under residual stress
- Consider small deflection case: $y(x) \ll L$



Governing differential equation: (Euler Beam Equation)

$$EI_z \frac{d^4 y}{dx^4} - S \frac{d^2 y}{dx^2} = F \delta(x-L)$$

Axial Load Force Unit impulse @ $x=L$

Need to solve this, then find the stiffness against this force @ this location

- Can solve the ODE using standard methods
 - ↳ Senturia, pp. 232-235: solves ODE for case of point load on a clamped-clamped beam (which defines B.C.'s)
 - ↳ For solution to the clamped-guided case: see S. Timoshenko, Strength of Materials II: Advanced Theory and Problems, McGraw-Hill, New York, 3rd Ed., 1955
- Result from Timoshenko: (Note: These include both loading & stretching)

$$S > 0 \text{ (tension)} \quad k^{-1} = \frac{pL - 2 \tanh(pL/2)}{p|S|} = \frac{y(x=L)}{F}$$

$$S < 0 \text{ (compression)}$$

$$k^{-1} = \frac{-pL + 2 \tan(pL/2)}{p|S|} = \frac{y(x=L)}{F}$$

where $p = \sqrt{\frac{|S|}{EI_z}}$ To use, must know

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Folded Beam Are Not Perfect

Inner beams
Outer beams
shoulder
 L_s
Tension
Compression
Compressive residual stress: offset expands
 ΔL_s
 L_s
stops in place
stops in place

④ This beam experiences tension.
③ Applies force on folding joint
② Compresses this beam
① Shoulder expands

Arch → moves w/ the substrate
effective arch (since the structure is symmetric)

Get s :

- ① If the polysil structural material stress is ϵ_r , then the shoulder expands $\Delta L_s = \epsilon_r L_s$
- ② This then applies a load to the beams, $\Delta L = \Delta L_s$.

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③ Beam Stress:

$$\epsilon_b = \frac{\Delta L}{2L} = \frac{\Delta L_s}{2L} = \pm \epsilon_r \frac{L_s}{2L}$$

↓

Stress force:

$$S = \pm E \epsilon_r \left(\frac{L_s}{2L} \right) Wh \text{ (axial tension)}$$

④ Spring Constants: 4 in parallel = $k_{com} // k_{ten}$

$$k = 4(k_{com}^{-1} + k_{ten}^{-1})^{-1}$$

$$k = 4 \left[\frac{-pL + 2 \tan(pL/2)}{p|S|} + \frac{pL - 2 \tanh(pL/2)}{p|S|} \right]^{-1}$$

Inner beams
Outer beams
 L_s
Tension
Compression
Compressive residual stress: offset expands
 ΔL_s
 L_s

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Same Problem as Before: Take a beam, apply a force.

① Apply force.

② Beam responds by bending.

③ This force has done work:

$$W = F \cdot y(L_c)$$

④ Strain generated.
 ↓
 So the beam has received an influx of stored energy.
 ↓
 magnitude of " " determined by shape.

⑤ Then

$$U = \text{Stored Energy} - \text{Work Done} \rightarrow 0$$

transfer function $y(x) = f(x)$

When we choose the right shape.
 ↓
 This is how we get the beam's response to f !